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JAN 15 2004

PATENT
(5298-04700/PM00028)IN THE UNITED STATES PATENT AND TRADEMARK OFFICEIn re Application of:
Gilboa et al.§ Group Art Unit: 1763
§ Examiner: Goudreau, G.

Serial No. 09/846,119

§ Atty. Dkt. No. 5298-04700

Filed: April 30, 2001

For: METHOD OF MAKING A
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STRUCTURE§ I hereby certify that this correspondence is being transmitted
§ via facsimile or deposited with the U.S. Postal Service with
§ sufficient postage as First Class Mail in an envelope addressed to:
§ Commissioner for Patents, P.O. Box 1450, Alexandria, VA
§ 22313, on the date indicated below:
§January 15, 2004
Date

Kevin D. Daffer

RESPONSE TO OFFICE ACTION MAILED OCTOBER 16, 2003Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir/Madam:

This paper is submitted in response to the Office Action mailed October 16, 2003 to further highlight reasons why the application is in condition for allowance.

Remarks begin on page 2 of this paper.